

82822



RECEIVED
JUN 16 2003
TC 1700

1765
PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Kozo Nakamura

Serial No.: 09/856,209

Filed: May 18, 2001

For: **SILICON CRYSTAL AND
PRODUCTION METHOD FOR
SILICON SINGLE CRYSTAL
WAFER**

Examiner: Matthew J. Song

) Art Unit: 1765

) Confirmation No.: 6736

) *I hereby certify that this
correspondence is being deposited
with the United Postal Service as first
class mail in an envelope addressed to:
Mail Stop Fee Amendment /
Commissioner for Patents / PO Box
1450 / Alexandria, Virginia 22313-
1450, on June 9, 2003:*

Gerald T. Shekleton

Gerald T. Shekleton Reg. No. 27,466

#10018
6/18/03
mw

AMENDMENT

MAIL STOP FEE AMENDMENT
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action of March 4, 2003 has been carefully reviewed and the following amendments and remarks are made in response thereto.

A Petition for Extension of Time Under 37 CFR 1.136(a) is enclosed.